



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/603,147
Filing Date June 23, 2000
Inventor John T. Moore et al.
Assignee Micron Technology, Inc.
Group Art Unit 2813
Examiner Kielin, Erik J.
Attorney's Docket No. MI22-1443
Title: Capacitor Constructions, DRAM Constructions and Semiconductive
Material Assemblies

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

To: Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

From: Jennifer J. Taylor, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)
Wells St. John P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828

Dear Sir:

The Examiner's attention is directed to the references which are listed on
the attached Form PTO-1449 and copies of which are attached.

Citation of these references is respectfully requested.

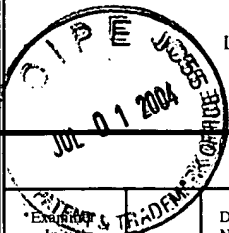
Respectfully submitted,

Dated:

July 1, 2004

By:

Jennifer J. Taylor
Jennifer J. Taylor, Ph.D.
Reg. No. 48,711

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-1443		SERIAL NO. 09/603,147	
<div style="float: left; width: 150px; text-align: center;">  </div> <div style="clear: both;"></div> <p>LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)</p>				APPLICANT John T. Moore et al.			
				FILING DATE June 23, 2000		GROUP 2813	
U.S. PATENT DOCUMENTS							
Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes No
	AM						
	AN						
	AO						
	AP						
	AQ						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AR		John L. Vossen, et al., "Thin Film Processes", Academic Press, 1978. p. 290				
	AS						
	AT						
EXAMINER				DATE CONSIDERED			
<small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>							